

**AMENDMENTS TO THE CLAIMS:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

**LISTING OF CLAIMS:**

1.-7. (Canceled)

8. (Currently Amended) A substrate storage container including:  
a container body of a front-opening box for storing substrates therein;  
a door for opening and closing the front of the container body; and  
an inner-pressure adjustment device attached to, at least, one of the container body and the door, for adjusting the pressure inside the container body closed with the door.

wherein the inner-pressure adjustment device comprises an elastic attachment cylinder formed in cylindrical shape having a first opening at one end face and a second opening smaller than the first opening at an other end face, a hollow filter support structure fitted into the attachment cylinder and a filter held inside the filter support structure.

9. (Canceled)

10. (Currently Amended) The substrate storage container according to Claim 8 [[9]], wherein an attachment hole for the attachment cylinder is formed in, at

least, one of the container body and the door, and a guide rib for the inner-pressure adjustment device is formed near the attachment hole.

11. (Currently Amended) The substrate storage container according to Claim 8 [[9]], wherein the attachment cylinder has a flange projected from the outer peripheral surface thereof for hooking the attachment hole, the filter support structure is formed of a pair of separate support pieces opposing each other, each supporting piece having an approximately cylindrical form, and the opposing parts of the supporting pieces are extended outwards with respect to the width direction, forming filter holders.

12. (Canceled)

13. (Previously Presented) The substrate storage container according to Claim 8, wherein shelf elements for supporting substrates are formed on both interior sides of the container body, and among the interior sides of the container body and the shelf elements, at least part of the substrate contact area of each shelf element is formed with a low-frictional resistance portion that is lower in frictional resistance than the non substrate contact area of the shelf element.

14. (Currently Amended) ~~The substrate storage container according to~~  
~~Claim 9, A substrate storage container including:~~  
a container body of a front-opening box for storing substrates therein;  
a door for opening and closing the front of the container body; and

an inner-pressure adjustment device attached to, at least, one of the container body and the door, for adjusting the pressure inside the container body closed with the door,

wherein shelf elements for supporting substrates are formed on both interior sides of the container body, and among the interior sides of the container body and the shelf elements, at least part of the substrate contact area of each shelf element is formed with a low-frictional resistance portion that is lower in frictional resistance than the non substrate contact area of the shelf element, each low-frictional resistance portion being formed by a texture transferred from a surface of a mold to a surface of the shelf element.

15. (Previously Presented) The substrate storage container according to Claim 8, wherein grooves for supporting substrates are formed at the interior backside of the container body, and the sectional shape of each groove is configured to be asymmetrical with respect to the center line of the substrate when the substrate is placed horizontally.

16. (Currently Amended) The substrate storage container according to Claim 14 [[9]], wherein grooves for supporting substrates are formed at the interior backside of the container body, and the sectional shape of each groove is configured to be asymmetrical with respect to the center line of the substrate when the substrate is placed horizontally.

17. (Previously Presented) The substrate storage container according to Claim 13, wherein the arithmetic average roughness of the low-frictional resistance portion is specified to be 0.2a or above in terms of the average roughness (Ra).

18. (Currently Amended) The substrate storage container according to Claim 14 [[13]], wherein the arithmetic average roughness of the low-frictional resistance portion is specified to be 0.2a or above in terms of the average roughness (Ra).